

First Named Inventor	Naoto Kawamura et al.
Serial No.	Filed Herewith
Filing Date	Filed Herewith
Group Art Unit	Unknown
Examiner Name	Unknown
Confirmation No.	Unknown
Attorney Docket No.	10991153-11

**INFORMATION
DISCLOSURE
STATEMENT**

Title: FLUID EJECTION DEVICE AND METHOD OF MANUFACTURE

Commissioner for Patents
 MS Patent Application
 P.O. Box 1450
 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

Further pursuant to 37 C.F.R. 1.98(d), because all of the references listed on the attached Form 1449 have been previously submitted and made of record in the grand-parent application, U.S. Patent Application 09/556,026, filed April 20, 2000, copies of the references previously made of record in the parent application are not submitted herewith.

INFORMATION DISCLOSURE STATEMENT

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If the Examiner has any questions or concerns regarding this application, please contact the undersigned at the number listed below.

Respectfully submitted,

Date: 09-09-2003

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PATENT APPLICATION

Sheet 1 of 1

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		ATTY. DOCKET NO. 10991153-11	APPLICATION NO.	CONFIRMATION NO.
		APPLICANT Naoto Kawamura et al.		
		FILING DATE Herewith	GROUP	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
	1A	4,622,574	November 1986	Garcia	
	1B	4,734,717	March 1988	Rayfield	
	1C	4,873,622	October 1989	Komuro et al.	
	1D	4,940,413	July 1990	Childers et al.	
	1E	5,389,962	February 1995	Sekiya et al.	
	1F	5,694,684	December 1997	Yamamoto	
	1G	6,039,439	March 2000	Komplin et al.	
	1H	6,099,109	August 2000	Komuro	
	1I	6,188,414	February 2001	Wong et al.	
	1J				
	1K				

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
	1L	EP 0593175A2	April 1994	Hewlett-Packard Co.		
	1M	EP 0646466A2	April 1995	Hewlett-Packard Co.		
	1N	WO 99/65690	Dec. 1999	Lexmark Int'l Inc.		
	1O	WO 99/65691	Dec. 1999	Lexmark Int'l Inc.		
	1P					

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

	1Q	
	1R	
	1S	

EXAMINER

DATE CONSIDERED